



J8W/2852

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Kenichi SHIRAISHI

Group Art Unit: 2852

Application No.: 10/588,146

Docket No.: 128985

Filed: November 6, 2006

For: EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD,
MAINTENANCE METHOD, AND EXPOSURE METHOD

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff
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JAO:KDB/nxy

Date: April 20, 2007

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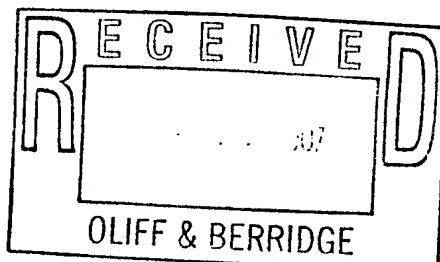
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APPL NO.	FILING OR 371(c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLMS	IND CLMS
10/588,146	11/06/2006	2852	1160	128985	10 17	2

25944
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CONFIRMATION NO. 3604

FILING RECEIPT



OC000000023188810

Date Mailed: 04/03/2007

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

Kenichi Shiraishi, ~~Saitama-ken~~, JAPAN;
 Saitama-shi

Assignment For Published Patent Application

Nikon Corporation, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/01827 02/08/2005

Foreign Applications

JAPAN-2004033679-02/10/2004

2004-033679

If Required, Foreign Filing License Granted: 03/30/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/588,146**

Projected Publication Date: 07/12/2007

Non-Publication Request: No

Early Publication Request: No

Title

Exposure apparatus, device manufacturing method, maintenance method, and exposure method

Preliminary Class

399

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ATTORNEYS AT LAW

Supplemental Application Data Sheet

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Kenichi
Family Name:: SHIRAISHI
City of Residence:: Saitama-shi
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type:: National Phase
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: EXPOSURE APPARATUS, DEVICE
MANUFACTURING METHOD,
MAINTENANCE METHOD, AND
EXPOSURE METHOD
Attorney Docket Number:: 128985
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 4
Small Entity:: No

Representative Information

Attorneys associated with Customer No. 25944.

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Phase of	PCT/JP2005/001827	02/08/05

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-033679	02/10/04	Yes
Assignee Information			
Assignee Name::		Nikon Corporation	
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Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		100-8331	